

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoshihiro ITO et al. Application No.: 10/518,945 Confirmation No.: 4943 Filing or 371(c) Date: July 13, 2005 Title: SEMICONDUCTOR DEVICE IN WHICH ZINC OXIDE IS USED AS A SEMICONDUCTOR MATERIAL AND METHOD FOR MANUFACTURING THE SEMICONDUCTOR DEVICE (AS AMENDED)	Art Unit: 2813 Examiner: T. Nguyen
--	---------------------------------------

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 12, 2008, the period for response to which has been extended to June 12, 2008, by the accompanying Petition for One-Month Extension of time, please amend the above-identified application as follows:

- ☒ **Amendments to the Specification** begin on page **2** of this paper.
- ☒ **Amendments to the Claims** are reflected in the listing of the claims which begins on page **3** of this paper.
- ☐ **Amendments to the Drawings** begin on page of this paper and include an attached replacement sheet. An **Appendix** including the amended drawing figures is attached following page of this paper.
- ☒ **Remarks/Arguments** begin on page **6** of this paper.

Please note, if a box is not checked, then no corresponding amendment is being made.